

Applicati n/Contr I No.	Applicant(s)/Patent und r R xamination SCHOUTEN ET AL.	
10/650,594		
Examiner	Art Unit	
Long Nauven	2816	

SEARCHED					
Class	Subclass	Date	Examiner		
327	77, 78, 83, 142, 143, 198, 512, 513	01/24/05	LN		
320	157-159, 162-164, 166				
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INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			
Search	nsore	01/24/05	W			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East	01/24/25	ω		
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